The present invention is related in general to the field of semiconductor devices and processes and more specifically to the materials and fabrication of leadframes for integrated circuit devices.

## 10 DESCRIPTION OF THE RELATED ART

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The leadframe for semiconductor devices was invented (US Patents # 3,716,764 and # 4,034,027) to serve several operation semiconductor devices their and of First of all, the leadframe provides a simultaneously: stable support pad for firmly positioning the semiconductor chip, usually an integrated circuit (IC) chip. Since the made of electrically is leadframe including the pads conductive material, the pad may be biased, when needed, to any electrical potential required by the network involving the semiconductor device, especially the ground potential.

Secondly, the leadframe offers a plurality of conductive segments to bring various electrical conductors into close proximity of the chip. The remaining gap between the ("inner") tip of the segments and the conductor pads on the IC surface are typically bridged by thin metallic wires, individually bonded to the IC contact pads and the leadframe segments. Obviously, the technique of wire bonding implies that reliable welds can be formed at the (inner) segment tips.

## WE CLAIM:

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1.	A	leadframe	for	use	with	integrated	circuit	chips
	C	omprising:						outer

a plated layer of gold selectively covering areas of said leadframe intended for solder attachment and said gold layer providing a visual distinction to said areas.

- 2. A leadframe for use with integrated circuit chips, having a chip mount pad and a plurality of lead segments, comprising:
  - a leadframe base made of copper or copper alloy;
  - a first layer of nickel deposited on said copper or copper alloy;
  - a layer of an alloy of nickel and palladium on said
     first nickel layer;
  - a second layer of nickel on said alloy layer, said second nickel layer deposited to be suitable for bending of said lead segments, wire bonding, and solder attachment;
  - a layer of palladium, said palladium layer deposited to be suitable for protecting the nickel surface for wire bonding and solderability, and for adhesion to molding compound; and
  - lead segments intended for solder attachments said

    layer of gold providing a visual distinction to

    said areas and having a thickness to optimize

    solder attachment.
- 30 3. The leadframe according to Claim 2 wherein said gold layer has a thickness in the range from 2 to 5 nm.
  - 4. The leadframe according to Claim 2 wherein said first nickel layer has a thickness in the range from 50 to 150